

<i>Notice of References Cited</i>	Applicant/Patent Weimer et al.		Application/Control No. 09/296,835	
	Examiner Erik Kielin		Art Unit 2813	Page 1 of 1

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Art Unit

2813

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	U	Van Zant, Microchip Fabrication, A Practical Guide to Semiconductor Processing, 3rd ed. McGraw-Hill: New York, 1997, pp. 157-160.
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² Classifications may be U.S. or foreign.